

Notice of References Cited	Application/Control No. 10/521,669		Applicant(s)/Patent Under Reexamination CHUNG ET AL.	
	Examiner Jeffrey T. Palenik		Art Unit 1615	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0059470	03-2003	Muller, Rainer H.	424/489
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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*	N	WO 02/13815 A1	02-2002	KR	Woo et al.	A61K 31/205
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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